SONY

ICX099AL

1/2-inch Progressive Scan CCD Image Sensor with Square Pixel for B/W Cameras

Description

The ICX099AL is a 1/2-inch optical interline CCD solid-state image sensor with a square pixel array and 800K effective pixels. Progressive scan allows all pixels' signals to be output independently within approximately 1/15 second. Also, the adoption of high-speed mode supports 30 frames per second. This chip features an electronic shutter with variable charge-storage time which makes it possible to realize high resolution, full-frame still image without a mechanical shutter. Further, high sensitivity and low dark current are achieved through the adoption of HAD (Hole-Accumulation Diode) sensors.

This chip is suitable for applications such as high resolution cameras for FA, etc.

Features

- Progressive scan allows individual readout of the image signals from all pixels.
- High horizontal and vertical resolution still image without a mechanical shutter.
- Supports 30 frames per second mode
- Square pixel
- Horizontal drive frequency: 14.31818MHz
- No voltage adjustments (reset gate and substrate bias are not adjusted.)
- · High resolution, high sensitivity, low dark current
- Continuous variable-speed shutter
- Low smear
- Excellent antiblooming characteristics

Device Structure

• Interline CCD image sensor

• Optical size: 1/2-inch format

Number of effective pixels: 1034 (H) × 779 (V) approx. 800K pixels
 Total number of pixels: 1077 (H) × 788 (V) approx. 850K pixels

• Chip size: 7.60mm (H) \times 6.20mm (V) • Unit cell size: 6.25 μ m (H) \times 6.25 μ m (V)

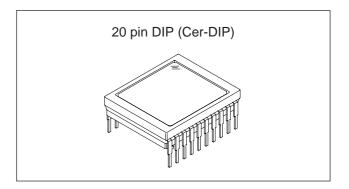
• Optical black: Horizontal (H) direction: Front 3 pixels, rear 40 pixels

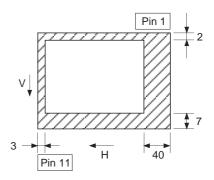
Vertical (V) direction: Front 7 pixels, rear 2 pixels

Number of dummy bits: Horizontal 29

Vertical 1

Substrate material: Silicon



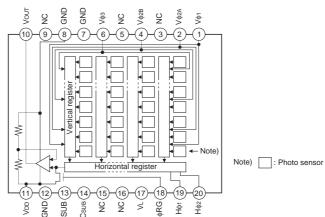


Optical black position (Top View)

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Block Diagram and Pin Configuration

(Top View)



Pin Description

Pin No.	Symbol	Description	Pin No.	Symbol	Description
1	V ₀ 1	Vertical register transfer clock	11	VDD	Supply voltage
2	Vф2A	Vertical register transfer clock	12	GND	GND
3	NC		13	φSUB	Substrate clock
4	Vф2B	Vertical register transfer clock	14	Сѕив	Substrate bias*1
5	NC		15	NC	
6	Vфз	Vertical register transfer clock	16	NC	
7	GND	GND	17	VL	Protective transistor bias
8	GND	GND	18	φRG	Reset gate clock
9	NC		19	Нф1	Horizontal register transfer clock
10	Vouт	Signal output	20	Нф2	Horizontal register transfer clock

 $^{^{*1}}$ DC bias is generated within the CCD, so that this pin should be grounded externally through a capacitance of 0.1 μ F.

Absolute Maximum Ratings

	Item	Ratings	Unit	Remarks
	Vdd, Vout, φRG – φSUB	-40 to +10	V	
	V _{\$\phi_2A\$} , V _{\$\phi_2B} - \$\phi_SUB\$	-50 to +15	V	
Against φSUB	Vφ1, Vφ3, VL – φSUB	-50 to +0.3	V	
	Hφ1, Hφ2, GND – φSUB	-40 to +0.3	V	
	Csuв – фSUB	-25 to	V	
	Vdd, Vout, фRG, Csuв – GND	-0.3 to +18	V	
Against GND	Vφ1, Vφ2A, Vφ2B, Vφ3 – GND	-10 to +18	V	
	Hφ1, Hφ2 – GND	-10 to +5	V	
Against V∟	Vф2A, Vф2B — VL	-0.3 to +28	V	
7.90	Vφ1, Vφ3, Hφ1, Hφ2, GND – VL	-0.3 to +15	V	
_	Voltage difference between vertical clock input pins	to +15	V	*2
Between input clock pins	Hφ1 – Hφ2	−5 to +5	V	
	$H\phi_1, H\phi_2 - V\phi_3$	-13 to +13	V	
Storage tempe	rature	-30 to +80	°C	
Operating temp	perature	-10 to +60	°C	

^{*2 + 24}V (Max.) when clock width < 10 μ s, clock duty factor < 0.1%.

Bias Conditions

Item	Symbol	Min.	Тур.	Max.	Unit	Remarks
Supply voltage	VDD	14.55	15.0	15.45	V	
Protective transistor bias	VL		*1			
Substrate clock	φSUB		*2			
Reset gate clock	φRG		*2			

^{*1} VL setting is the V_{VL} voltage of the vertical transfer clock waveform, or the same power supply as the V_L power supply for the V driver should be used.

DC Characteristics

Item	Symbol	Min.	Тур.	Max.	Unit	Remarks
Supply current	IDD		6.0		mA	

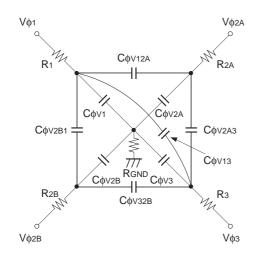
Clock Voltage Conditions

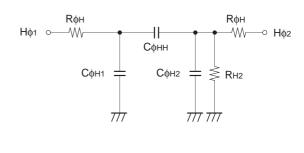
Item	Symbol	Min.	Тур.	Max.	Unit	Waveform diagram	Remarks
Readout clock voltage	VvT	14.55	15.0	15.45	V	1	
	VvH02A	-0.05	0	0.05	V	2	Vvh = Vvh02A
	Vvh1, Vvh2A, Vvh2B, Vvh3	-0.2	0	0.05	V	2	
	VVL1, VVL2A, VVL2B, VVL3	-5.8	-5.5	-5.2	V	2	VvL = (VvL1+VvL3)/2
Vertical transfer clock voltage	Vφ1, Vφ2A, Vφ2B, Vφ3	5.2	5.5	5.8	V	2	
	VVL1 – VVL3			0.1	٧	2	
	V∨нн			0.3	V	2	High-level coupling
	VVHL			1.0	V	2	High-level coupling
	VVLH			0.5	V	2	Low-level coupling
	VVLL			0.5	V	2	Low-level coupling
Horizontal transfer	Vфн	4.75	5.0	5.25	V	3	
clock voltage	VHL	-0.05	0	0.05	V	3	
	Vþrg	3.0	3.3	5.5	V	4	
Reset gate clock voltage	Vrglh – Vrgll			0.4	V	4	Low-level coupling
	VRGL - VRGLm			0.5	V	4	Low-level coupling
Substrate clock voltage	Vфѕив	19.75	20.5	21.25	V	5	

^{*2} Do not apply a DC bias to the substrate clock and reset gate clock pins, because a DC bias is generated within the CCD.

Clock Equivalent Circuit Constant

Item	Symbol	Min.	Тур.	Max.	Unit	Remarks
	СфV1		2200		pF	
Capacitance between vertical transfer clock and GND	Сфу2А, Сфу2В		1800		pF	
	Сф∨з		6800		pF	
	СфV12А, СфV2В1		1200		pF	
Capacitance between vertical transfer clocks	Сфу2А3, Сфу32В		1000		pF	
	СфV13		1500		pF	
Capacitance between horizontal transfer clock and GND	Сфн1, Сфн2		56		pF	
Capacitance between horizontal transfer clocks	Сфнн		120		pF	
Capacitance between reset gate clock and GND	Сфяд		10		pF	
Capacitance between substrate clock and GND	Сфѕив		400		pF	
Vertical transfer clock series resistor	R1, R2A, R2B, R3		30		Ω	
Vertical transfer clock ground resistor	RGND		30		Ω	
Horizontal transfer clock series resistor	Rфн		20		Ω	
Horizontal transfer clock ground resistor	RH2		20		kΩ	





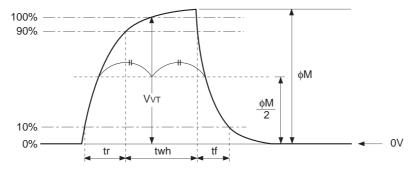
Vertical transfer clock equivalent circuit

Horizontal transfer clock equivalent circuit

Drive Clock Waveform Conditions

(1) Readout clock waveform

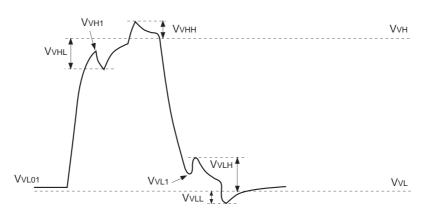




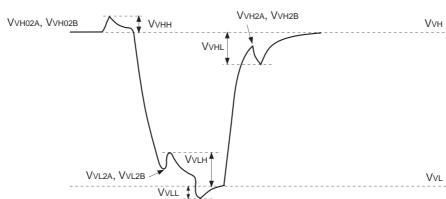
Note) Readout clock is used by composing vertical transfer clocks V_{\$\psi\$2A}\$ and V_{\$\psi\$2B\$}.}

(2) Vertical transfer clock waveform

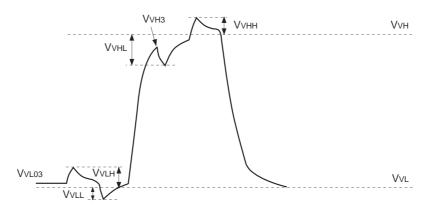




Vφ2A, Vφ2B

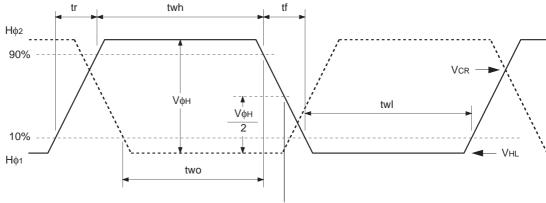


Vфз

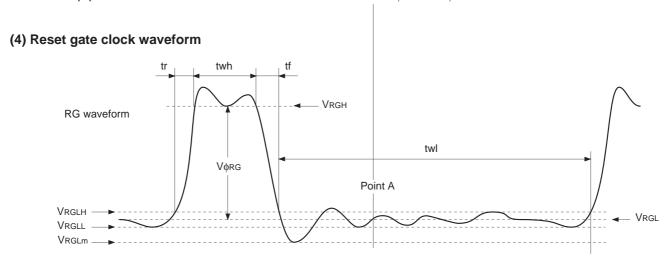


$$\begin{split} V\varphi v_1 &= Vvh_1 - Vvl_{01} \\ V\varphi v_{2A} &= Vvh_{02A} - Vvl_{2A} \\ V\varphi v_{2B} &= Vvh_{02B} - Vvl_{2B} \end{split}$$
 $V\phi V3 = VVH3 - VVL03$

(3) Horizontal transfer clock waveform



Cross-point voltage for the H ϕ 1 rising side of the horizontal transfer clocks H ϕ 1 and H ϕ 2 waveforms is Vcr. The overlap period for twh and twl of horizontal transfer clocks H ϕ 1 and H ϕ 2 is two.



VRGLH is the maximum value and VRGLL is the minimum value of the coupling waveform during the period from Point A in the above diagram until the rising edge of RG. In addition, VRGL is the average value of VRGLH and VRGLL.

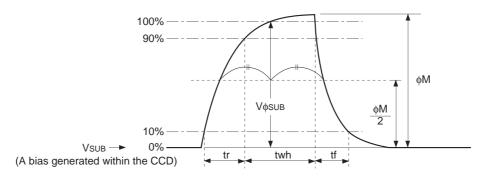
$$V_{RGL} = (V_{RGLH} + V_{RGLL})/2$$

Assuming VRGH is the minimum value during the interval twh, then:

$$V \phi RG = V RGH - V RGL$$

Negative overshoot level during the falling edge of RG is VRGLm.

(5) Substrate clock waveform



Clock Switching Characteristics

	Item	Symbol		twh			twl			tr			tf		Unit	Remarks
	пеш	Symbol	Min.	Тур.	Мах.	Min.	Тур.	Мах.	Min.	Тур.	Мах.	Min.	Тур.	Max.	Offic	Remarks
Rea	adout clock	VT	2.3	2.5						0.5			0.5		μs	During readout
Ver	tical transfer ck	Vф1, Vф2A, Vф2B, Vф3										15		350	ns	*1
충	During	Нф1	19	24		21	26			10	15		10	15	20	*2
r clo	imaging	Нф2	21	26		19	24			10	15		10	15	ns	_
Horizontal transfer clock	During	Нф1								0.01			0.01			
Ha tra	parallel-serial conversion	Нф2								0.01			0.01		μs	
Res	set gate clock	фRG	11	13			51			3			3		ns	
Suk	ostrate clock	фѕив	1.5	1.8							0.5			0.5	μs	During drain charge

^{*1} When vertical transfer clock driver CXD1267AN × 2 are used.

^{*2} tf \geq tr - 2ns, and the cross-point voltage (VcR) for the H ϕ 1 rising side of the H ϕ 1 and H ϕ 2 waveforms must be at least V ϕ H/2 [V].

Item	Symbol		two		Unit	Remarks
item	Gymbol	Min.	Тур.	Мах.	Offic	Remarks
Horizontal transfer clock	Нф1, Нф2	16	20		ns	

Spectral Sensitivity Characteristics (excludes lens characteristics and light source characteristics)

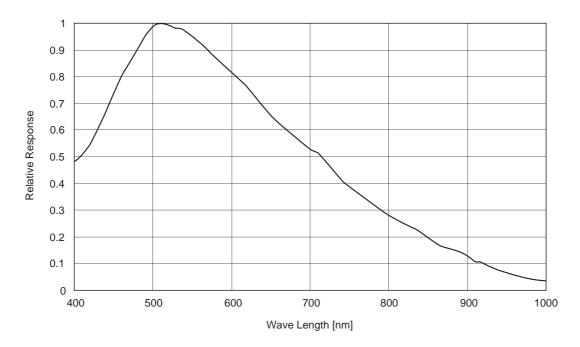
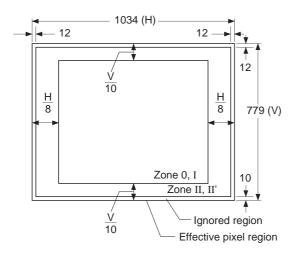


Image Sensor Characteristics

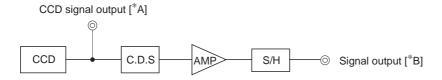
 $(Ta = 25^{\circ}C)$

Item	Symbol	Min.	Тур.	Max.	Unit	Measurement method	Remarks
Sensitivity	S	480	600		mV	1	1/30s accumulation mode
Saturation signal	Vsat	500			mV	2	Ta = 60°C
Smear	Sm		0.001	0.0025	%	3	1/15s accumulation mode
Video signal shading	SH			20	%	4	Zone 0 and I
Video signal shading	ЗП			25	%	4	Zone 0 to II'
Dark signal	Vdt			8	mV	5	Ta = 60°C
Dark signal shading	ΔVdt			2	mV	6	Ta = 60°C
Lag	Lag			0.5	%	7	

Zone Definition of Video Signal shading



Measurement System

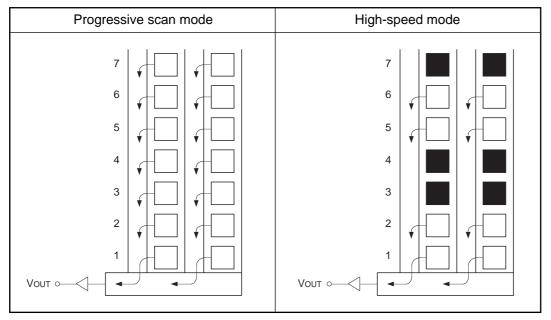


Note) Adjust the amplifier gain so that the gain between [*A] and [*B] equals 1.

Image Sensor Characteristics Measurement Method

Readout modes

The diagram below shows the output methods for the following two readout modes.



Note) Blacked out portions in the diagram indicate pixels which are not read out.

1. Progressive scan mode

In this mode, all pixel signals are output in non-interlace format in 1/15s.

The vertical resolution is approximately 760TV-lines and all pixel signals within the same exposure period are read out simultaneously, making this mode suitable for high resolution image capturing.

2. High-speed mode

The signals for all effective areas are output in approximately 1/30s by repeating readout pixels and non-readout pixels every two lines. The vertical resolution is approximately 380TV-lines.

This readout mode emphasizes processing speed over vertical resolution.

Measurement conditions

1) In the following measurements, the device drive conditions are at the typical values of the bias and clock voltage conditions.

2) In the following measurements, spot blemishes are excluded and, unless otherwise specified, the optical black level (OB) is used as the reference for the signal output, which is taken as the value measured at point [*B] of the measurement system.

O Definition of standard imaging conditions

1) Standard imaging condition I:

Use a pattern box (luminance : 706cd/m^2 , color temperature of 3200K halogen source) as a subject. (pattern for evaluation is not applicable.) Use a testing standard lens with CM500S (t = 1.0mm) as an IR cut filter and image at F8. The luminous intensity to the sensor receiving surface at this point is defined as the standard sensitivity testing luminous intensity.

2) Standard imaging condition II:

Image a light source (color temperature of 3200K) with a uniformity of brightness within 2% at all angles. Use a testing standard lens with CM500S (t = 1.0mm) as an IR cut filter. The luminous intensity is adjusted to the value indicated in each testing item by the lens diaphragm.

1. Sensitivity

Set to standard imaging condition I. After selecting the electronic shutter mode with a shutter speed of 1/250s, measure the signal output (Vs) at the center of the screen, and substitute the value into the following formula.

$$S = Vs \times \frac{250}{30} \text{ [mV]}$$

2. Saturation signal

Set to standard imaging condition II. After adjusting the luminous intensity to 10 times the intensity with the average value of the signal output, 150mV, measure the minimum value of the signal output.

3. Smear

Set to standard imaging condition II. With the lens diaphragm at F5.6 to F8, first adjust the luminous intensity to 500 times the intensity with the average value of the signal output, 150mV. Then after the readout clock is stopped and the charge drain is executed by the electronic shutter at the respective H blankings, measure the maximum value (Vsm [mV]) of the signal output and substitute the value into the following formula.

$$Sm = \frac{Vsm}{150} \times \frac{1}{500} \times \frac{1}{10} \times 100 \text{ [\%] (1/10V method conversion value)}$$

4. Video signal shading

Set to standard imaging condition II. With the lens diaphragm at F5.6 to F8, adjust the luminous intensity so that the average value of the signal output is 150mV. Then measure the maximum (Vmax [mV]) and minimum (Vmin [mV]) values of the signal output and substitute the values into the following formula.

$$SH = (Vmax - Vmin)/150 \times 100 [\%]$$

5. Dark signal

Measure the average value of the signal output (Vdt [mV]) with the device ambient temperature 60°C and the device in the light-obstructed state, using the horizontal idle transfer level as a reference.

6. Dark signal shading

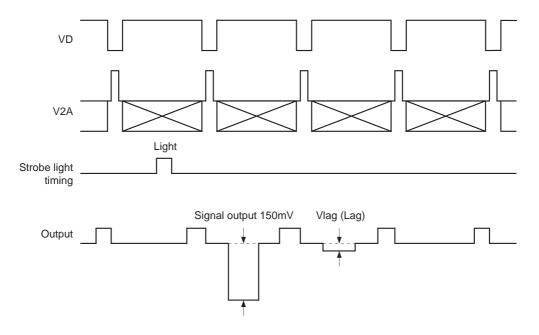
After measuring 5, measure the maximum (Vdmax [mV]) and minimum (Vdmin [mV]) values of the dark signal output and substitute the values into the following formula.

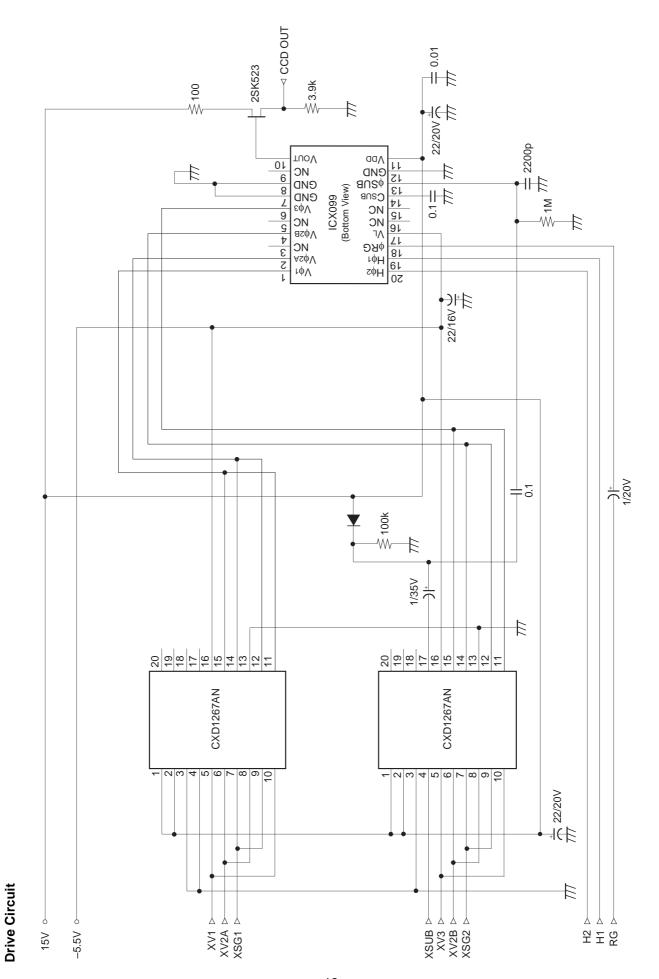
 $\Delta Vdt = Vdmax - Vdmin [mV]$

7. Lag

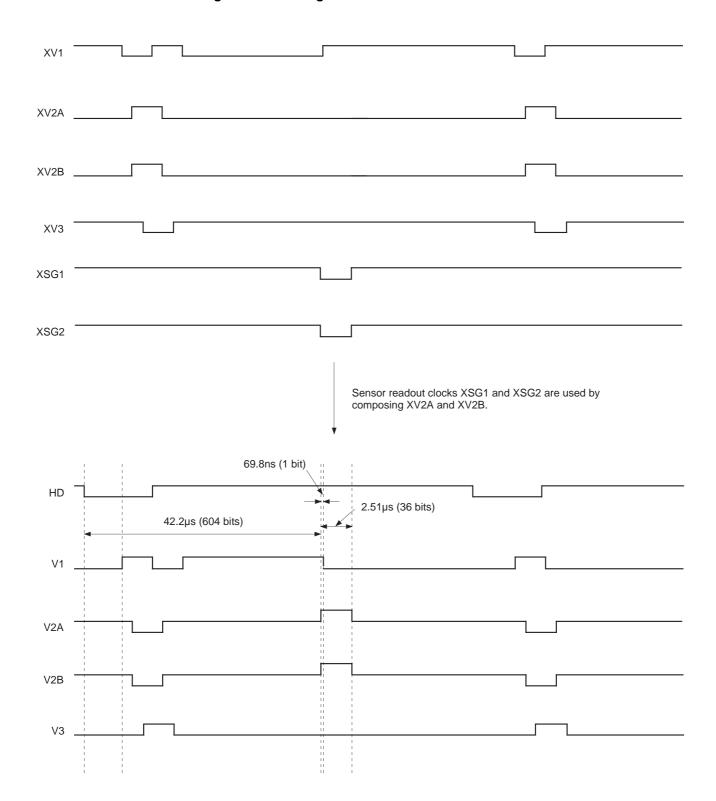
Adjust the signal output value generated by strobe light to 150mV. After setting the strobe light so that it strobes with the following timing, measure the residual signal (Vlag). Substitute the value into the following formula.

 $Lag = (Vlag/150) \times 100 [\%]$

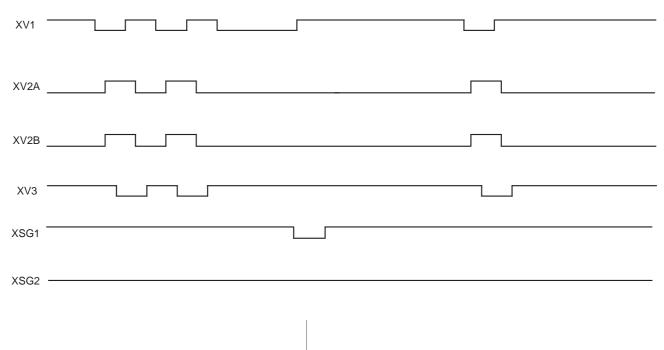




Sensor Readout Clock Timing Chart Progressive Scan Mode

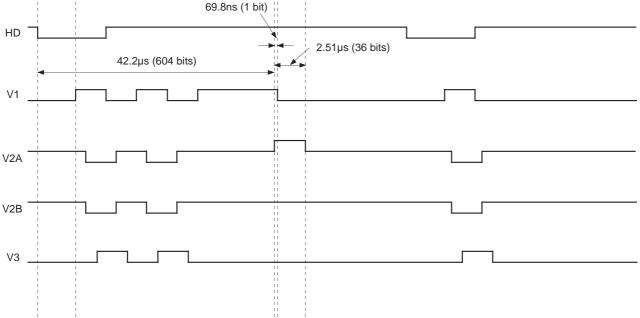


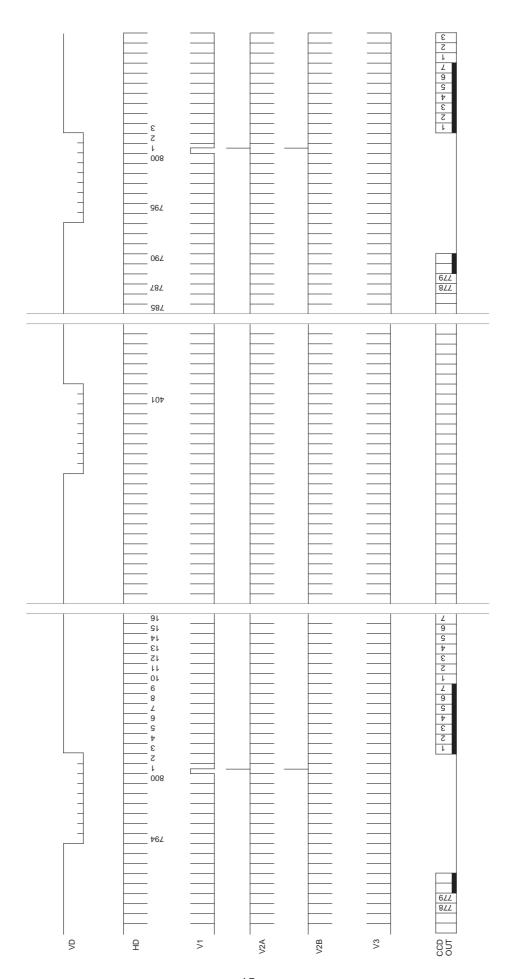
Sensor Readout Clock Timing Chart High-speed Mode

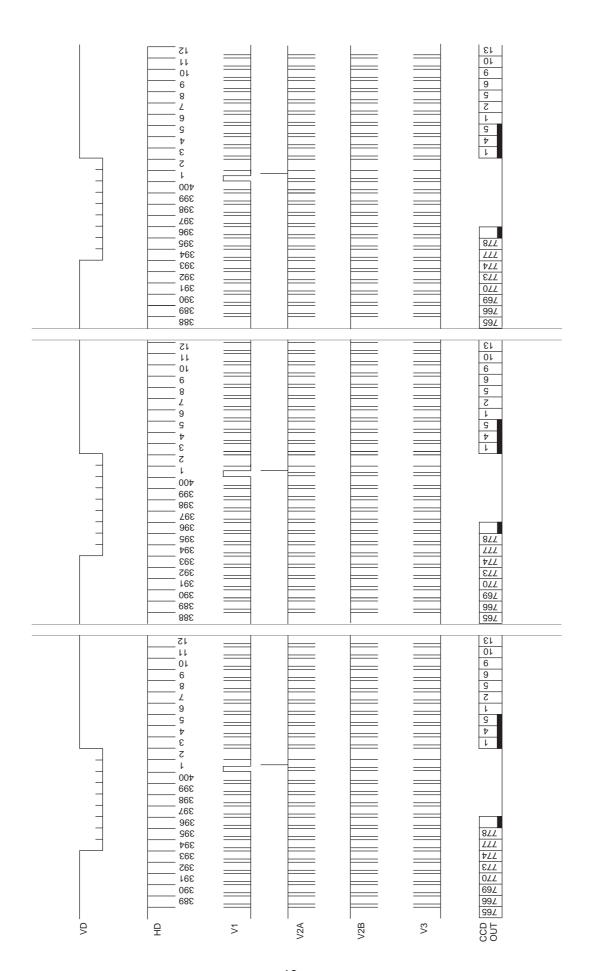


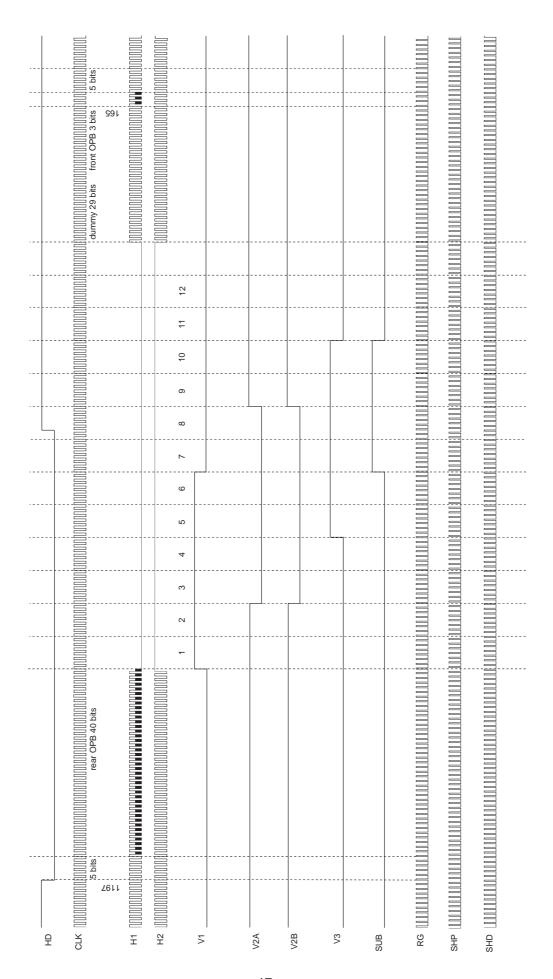
Sensor readout clock XSG1 is used by composing XV2A.

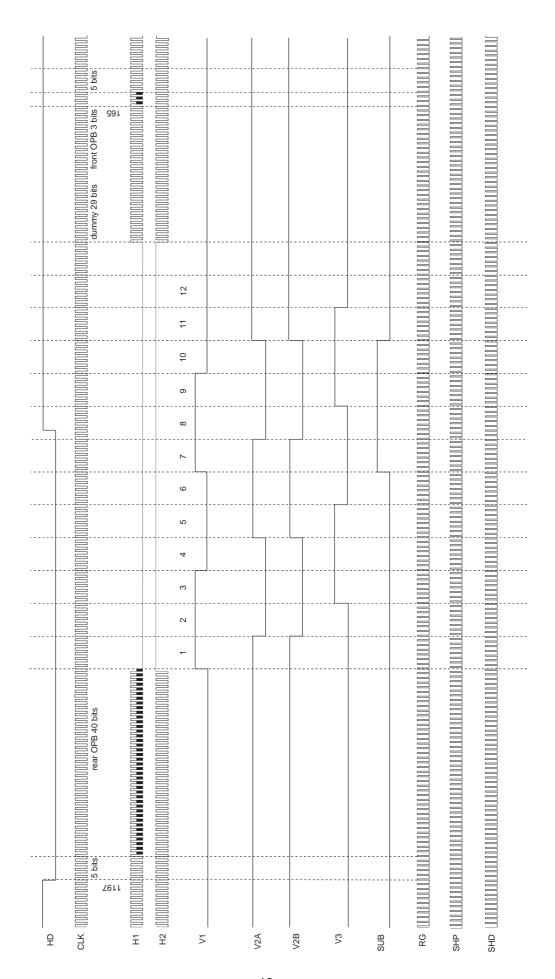
69.8ns (1 bit)











Notes on Handling

1) Static charge prevention

CCD image sensors are easily damaged by static discharge. Before handling be sure to take the following protective measures.

- a) Either handle bare handed or use non-chargeable gloves, clothes or material. Also use conductive shoes.
- b) When handling directly use an earth band.
- c) Install a conductive mat on the floor or working table to prevent the generation of static electricity.
- d) Ionized air is recommended for discharge when handling CCD image sensor.
- e) For the shipment of mounted substrates, use boxes treated for the prevention of static charges.

2) Soldering

- a) Make sure the package temperature does not exceed 80°C.
- b) Solder dipping in a mounting furnace causes damage to the glass and other defects. Use a ground 30W soldering iron and solder each pin in less than 2 seconds. For repairs and remount, cool sufficiently.
- c) To dismount an image sensor, do not use a solder suction equipment. When using an electric desoldering tool, use a thermal controller of the zero cross On/Off type and connect it to ground.

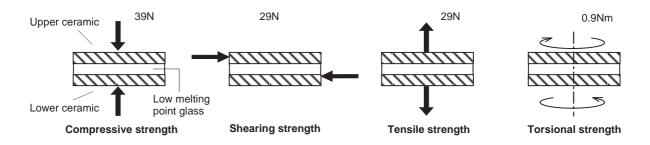
3) Dust and dirt protection

Image sensors are packed and delivered by taking care of protecting its glass plates from harmful dust and dirt. Clean glass plates with the following operation as required, and use them.

- a) Perform all assembly operations in a clean room (class 1000 or less).
- b) Do not either touch glass plates by hand or have any object come in contact with glass surfaces. Should dirt stick to a glass surface, blow it off with an air blower. (For dirt stuck through static electricity ionized air is recommended.)
- c) Clean with a cotton bud and ethyl alcohol if the grease stained. Be careful not to scratch the glass.
- d) Keep in a case to protect from dust and dirt. To prevent dew condensation, preheat or precool when moving to a room with great temperature differences.
- e) When a protective tape is applied before shipping, just before use remove the tape applied for electrostatic protection. Do not reuse the tape.

4) Installing (attaching)

a) Remain within the following limits when applying a static load to the package. Do not apply any load more than 0.7mm inside the outer perimeter of the glass portion, and do not apply any load or impact to limited portions. (This may cause cracks in the package.)



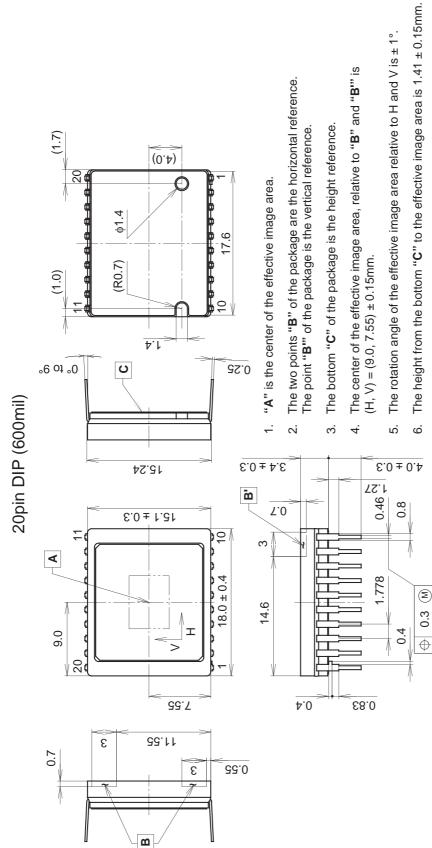
b) If a load is applied to the entire surface by a hard component, bending stress may be generated and the package may fracture, etc., depending on the flatness of the ceramic portions. Therefore, for installation, use either an elastic load, such as a spring plate, or an adhesive.

- c) The adhesive may cause the marking on the rear surface to disappear, especially in case the regulated voltage value is indicated on the rear surface. Therefore, the adhesive should not be applied to this area, and indicated values should be transferred to other locations as a precaution.
- d) The upper and lower ceramic are joined by low melting point glass. Therefore, care should be taken not to perform the following actions as this may cause cracks.
 - Applying repeated bending stress to the outer leads.
 - Heating the outer leads for an extended period with a soldering iron.
 - Rapidly cooling or heating the package.
 - Applying any load or impact to a limited portion of the low melting point glass using tweezers or other sharp tools.
 - Prying at the upper or lower ceramic using the low melting point glass as a fulcrum.
 Note that the same cautions also apply when removing soldered products from boards.
- e) Acrylate anaerobic adhesives are generally used to attach CCD image sensors. In addition, cyanoacrylate instantaneous adhesives are sometimes used jointly with acrylate anaerobic adhesives. (reference)

5) Others

- a) Do not expose to strong light (sun rays) for long periods. For continuous using under cruel condition exceeding the normal using condition, consult our company.
- b) Exposure to high temperature or humidity will affect the characteristics. Accordingly avoid storage or usage in such conditions.

Package Outline Unit: mm



PACKAGE STRUCTURE

PACKAGE MATERIAL	Cer-DIP
LEAD TREATMENT	TIN PLATING
LEAD MATERIAL	42 ALLOY
PACKAGE WEIGHT	2.6g

o	The tilt of the effective image area relative to the bottom " $oldsymbol{c}$ " is less than 60 μ m.	The thickness of the cover glass is 0.75mm, and the refractive index is 1.5.
D	The tilt of the effective	The thickness of the cc

The notch and the hole on the bottom must not be used for reference of fixing.

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